

*#1/4 Etk.
NO Wilson
5/30/02*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Brase
Serial No.: 09/501,124
Filed: February 9, 2000
Entitled: Self-Aligned Dual Damascene Etch Using a
Polymer

Group Art Unit: 2818

Examiner: Gurley, L

Docket No.: 00 P 7456 US

Certificate of Facsimile TransmissionUnder 37 CFR §1.8(a)(1)(i)(B)

I hereby certify that this correspondence is being transmitted by
facsimile to the Patents and Trademark Office on May 17, 2002 to
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On: May 17, 2002Signed: 

Stanton Braden, Reg. # 32,556

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MAY 17 2002

Assistant Commissioner for Patents
Washington, D.C. 20231

TECHNOLOGY CENTER 2800

Petition and Fee for Extension of Time Submitted
Pursuant to 37 CFR § 1.136(a)

Sir:


On March 26, 2002 an Office action was issued in the above-referenced application,
setting a one-month shortened statutory period for response.

This is a petition for a one-month extension of time pursuant to 37 CFR § 1.136(a).

Please charge Deposit Account No. 19-2179, \$110.00 or any other appropriate amount in
accordance with 37 CFR § 1.17(a).

If this petition is for an incorrect time period or if the above balance due is incorrect,
please treat this paper as a petition for the appropriate period and fee and charge/credit any fee
deficiencies/overpayments to Deposit Account No. 19-2179.

Respectfully submitted,


Stanton Braden
Reg. No. 32, 556
Attorney for Applicants

Infineon Technologies North America Corp.
c/o Siemens Corporation
185 Wood Avenue South
Iselin, NJ 08830
Tel.: (732) 321-3150
Fax: (732) 321-3030